



U.S. Department of Commerce, Patent and Trademark Office

Attorney Docket No.: 026-0041

Application No.: 10/814,816

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Applicant(s): Ligang Zhang et al.

(Use several sheets if necessary)

Filing Date: March 31, 2004

Group Art Unit: Not yet assigned

Date Submitted: April 30, 2004

## U.S. Patent Documents

*Examiner Initial		Document Number	Date	Name
JEM	AA	5,083,236	Jan. 21, 1992	Chason et al.
JEM	AB	5,461,353	Oct. 24, 1995	Eberhardt
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JEM	AD	6,362,525	Mar. 26, 2002	Rahim
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	AH			
	AI			
	AJ			
	AK			

## Foreign Patent Documents

					Translation	
		Document	Date	Country	Yes	No
JEM	AL	0 675 539 A2	Oct. 4, 1995	Europe		
JEM	AM	WO 02/067326 A2	Aug. 29, 2002	PCT		
	AN					
	AP					

## OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

JEM	AR	"Unitive - CSP On the Edge", Unitive Inc. 2003 (from website - <a href="http://www.unitive.com/cspedge/index.cfm">http://www.unitive.com/cspedge/index.cfm</a> ), 2 pages.
JEM	AS	"Unitive Design Guidelines", <a href="http://www.unitive.com">www.unitive.com</a> , 2001, pp. 1-18.
	AT	

Examiner

Jennifer E. Motiwale

Date Considered

3-17-06

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.



PTO/SB/08B (Substitute for form 1449/PTO)		Attorney Docket No.: 026-0041	
		Application No.: 10/814,816	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		First Named Inventor: Ligang Zhang	
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		Group Art Unit: 2811	
		Examiner Name: Jennifer E. Matisiak	
Sheet 1 of 1		Date Submitted: September 23, 2005	
NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. <sup>1</sup>	Include name of author (in CAPITAL LETTERS), title of article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
JEM	AA	FROMMBERGER, Michael, et al., "Integration of Crossed Anisotropy Magnetic Core Into Toroidal Thin-Film Inductors," IEEE Transactions on Microwave Theory and Techniques, Vol. 53, No. 6, June 2005, pp. 2096-2100.	
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Examiner Signature	Jennifer E. Matisiak		Date Considered 3-17-06

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<sup>1</sup>Applicant's unique citation designation number (optional).

<sup>2</sup>Applicant is to place a check mark here if English language Translation is attached.